



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Karen Schlicht et al.

Serial No.:

10/665,412

For:

METHOD FOR THE REMOVAL OF AN IMAGING LAYER FROM A

SEMICONDUCTOR SUBSTRATE STACK

Filed:

September 18, 2003

Examiner:

Kathleen Duda

Art Unit:

1756

Confirmation No.:

4389

Customer No.:

27,623

Attorney Docket No.: 335.7697USU

Mail Stop Amendment COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

<u>AMENDMENT TRANSMITTAL</u>

We are enclosing an Amendment in response to the communication dated March 22, 2005 in the above-identified application.

	Petition for extension of time pursuant to 37 C.F.R. §§ 1.136 and 1.137 is hereby
made	if, and to the extent, required. The fee for this extension of time is calculated to
be \$	to extend the time for filing this response until

The fee for any change in number of claims has been calculated as shown below.

		C	LAIMS AS	AMEND	DED		
·	Claims Remaining After Amendment		Nur Prev	hest nber iously aid	Present Extra	Rate	
Total Claims	68	Minus	68		0	x \$50.00	\$
Independent Claims	3	Minus	3		0	x \$200.00	\$
MULT	IPLE DEPENDEN	T CLAIM FEE					x \$360.00 = \$
TOTA	AL FEE FOR CLAI	M CHANGES					\$0.00
1/2 FILING FEE	FOR SMALL EN	ΓΙΤΥ					\$N/A

A check in the amount	of \$ <u>0.00</u> is attached.
C.F.R. §§1.16 and 1.17 which	hereby authorized to charge any additional fees under 37 h may be required with this communication or during the ation, or credit any overpayment, to Deposit Account No. f this Form is enclosed.
June 22, 2005	Paul D. Greeley, Esq.
Date	Attorney for Applicant(s) Registration No. ******** 31,019
	Ohlandt, Greeley, Ruggiero & Perle, L.L.P. One Landmark Square, 10 th Floor Stamford, CT 06901-2682
	Telephone: (203) 327-4500 Telefax: (203) 327-6401
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Ruth J. Olivo NAME	SIGNATURE June 22, 2005 DATE
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AMENDMENT

Dear Sir:

In response to an Office Action mailed on March 22, 2005, in reference to the above-referenced Application, Applicants respectfully submit the following Amendment.

Claim Status begins on page 2 of this paper.

Remarks/Arguments begin on page 13 of this paper.